

THE UNITED STATES PATENT AND TRADEMARK OFFICE

POWER OF ATTORNEY

Docket No.

90065.001020/17732.8011.0

Name of Applicant:

Fairchild Semiconductor Corporation

Address of Applicant:

82 Running Hill Road

South Portland, ME 04106

CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND

SEMICONDUCTOR DEVICED FORMED BY THOSE METHODS

Serial No., if Any:

09/682,151

Filed:

Title:

July 27, 2001

TO THE ASSISTANT COMMISSIONER FOR PATENTS

The Assistant Commissioner for Patents Washington, D.C. 20231

Honorable Sir:

I hereby appoint:

Thomas R. FitzGerald, Reg. No. 26,730

as principal attorneys to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

Please direct all future correspondence to:

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Assistant Secretary

Dated: 27 August 2002